PEVO	COPY OF PAPERS	17c1) 165
TRANSMETTAL LETTER (General - Patent Pending)	ORIGITY	Docket No. E0520CIP
In Re Application of: Kashpan Schota, Diana M. Schonauer, Johannes F. Groschopf, Gerd F.C. Marxsen, Steven A. Avanzino ORIGINALLY FILE AND ORIGINAL TO OR		
Serial No. Filing Date	Examiner	Group Art Unit
09/749,191 December 26, 2000	L. Umez-Eronini	1765
Title: "PREVENTION OF PRECIPITATION DEFECTS ON COPPER INTERCONNECTS DURING CMP BY USE SOLUTIONS CONTAINING ORGANIC COMPOUNDS WITH SILICA ADSORPTION AND COPPER CORROSION INHIBITING PROPERTIES"		
TO THE ASSISTANT COMMISSIONER FOR PATENTS:		
Transmitted herewith is:		RECO
Response to Restriction Requirement Return Receipt Postcard		RECEIVED MAR 27 2002 TC 1700
in the above identified application.		-
No additional fee is required. ☐ A check in the amount of is attach ☐ The Assistant Commissioner is hereby authorized to as described below. A duplicate copy of this sheet is ☐ Charge the amount of ☐ Credit any overpayment. ☐ Charge any additional fee required.	charge and credit Deposit A	RECEIVED TC 1700
Deborah W. Wenocur, Reg. No. 40,221 Agent for Applicant	Dated: December 5, 2001	
Advanced Micro Devices, Inc. Technology Law Dept. M/S 68 One AMD Place P.O. Box. 3453 Sunnyvale, CA 94088-3453	on Dec. 6, 2001 first class mail unde Assistant Commiss 20231.	with the U.S. Postal Service as er 37 C.F.R. 1.8 and is addressed to the sioner for Patents, Washington, D.C. W. W. S. Washington, D.C.

CC:

Deborah W. Wenocur

Typed or Printed Name of Person Mailing Correspondence